



State-of-the-Art Laser Measurement Technologies

Guest Editors:

Prof. Dr. Yufei Ma

National Key Laboratory of
Science and Technology on
Tunable Laser, Harbin Institute of
Technology, Harbin 150006,
China

Prof. Dr. Yong Zhao

College of Information Science
and Engineering, Northeastern
University, Shenyang 110819,
China

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Message from the Guest Editors

Dear Colleagues,

Laser measurement technologies are widely used for the online measurements of physical, biological, and chemical quantities. In the past years, laser measurement technologies have undergone rapid development because of the emergence of advanced light source and detection strategies. Laser measurement technologies have been adopted in many applications, such as environmental monitoring, industrial process, image diagnosis, and planetary exploration. The most prominent feature of laser measurement technologies is that the measurement is without contact and the speed is ultrafast because of the characteristics of light. Furthermore, the precision of laser-based measurement is attractive. Up until now, various laser measurement methods have been successfully invented for a variety of measuring tasks.

In this Special Issue, papers about laser measurement techniques, especially about some state-of-the-art methods, are welcomed; review articles are also encouraged.

Prof. Dr. Yufei Ma
Dr. Yong Zhao
Guest Editors





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Editor-in-Chief

Prof. Dr. Giulio Nicola Cerullo

Dipartimento di Fisica,
Politecnico di Milano, Piazza L.
da Vinci 32, 20133 Milano, Italy

Message from the Editor-in-Chief

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